Application/Control No. Applicant(s)/Patent Under Reexamination 09/905,157 Notice of References Cited LEWIS ET AL. Examiner Art Unit Page 1 of 1, Erik Kielin 2813 U.S. PATENT DOCUMENTS **Document Number** Date Country Code-Number-Kind Code MM-YYYY Name Classification В US-С US-US-D US-Ε ÙS-G US-US-US-US-K US-US-٠ نال ا US-FOREIGN PATENT DOCUMENTS Document Number Date Country Code-Number-Kind Code Country MM-YYYY Name Classification 0 Q R S Т NON-PATENT DOCUMENTS Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) Wolf, et al. Silicon Processing for the VLSI Era, Vol. 1-Process Technology, Lattice Press: Sunset Beach CA, 1986, p. 5.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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